DOCKET NO: 295715US26PCT

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

MASARU SASAKI, ET AL. : EXAMINER: MALEK, MALIHEH

SERIAL NO: 10/591,343 :

FILED: AUGUST 31, 2006 : GROUP ART UNIT: 2813

FOR: METHOD FOR MANUFACTURING :

SEMICONDUCTOR DEVICE AND PLASMA OXIDATION METHOD

## **REQUEST FOR RECONSIDERATION**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action of October 22, 2008, Applicants request reconsideration in view of the following remarks.

Remarks begin on page 2 of this paper.